

In re application of: Kim et al.

Serial No.: 10/787,368

Group: Art Unit 1752

Filed: February 26, 2004

Examiner: Walke, Amanda C.

For:

**METHOD OF FORMING AN UNDERLAYER OF A BILAYER RESIST FILM
AND METHOD OF FABRICATING A SEMICONDUCTOR DEVICE USING
THE SAME**

Mail Stop Amendment
Commissioner for Patents
PO Box 1450
Alexandria VA 22313-1450

AMENDMENT TRANSMITTAL FORM

Sir:

Transmitted herewith is an amendment in the above-identified application.

- [] Small entity status of this application under 37 C.F.R. § 1.9 and 1.27 has been established by a verified statement previously submitted.
- [] A verified statement to establish small entity under 37 C.F.R. § 1.9 and 1.27 is enclosed.
- [X] No additional fee is required.

The fee has been calculated as shown below:

	(Col. 1)	(Col. 2)	(Col. 3)	SMALL ENTITY	OTHER THAN SMALL ENTITY				
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDIT. FEE	OR	RATE	ADDIT. FEE	
TOTAL	31 *	MINUS	33** = 0	X	9	\$ 0	X	18	\$.00
INDEP.	4*	MINUS	4*** = 0	X	44	\$ 0	X	88	\$.00
[] FIRST PRESENTATION OF MULTIPLE DEP. CLAIM				X	150	\$	X	300	\$
TOTAL					OR TOTAL				
ADDIT. FEE					\$.00				

*If the entry in Co. 1 is less than entry in Col. 2, write "0" in Col. 3.

**If the "Highest No. Previously Paid for" IN THIS SPACE is less than 20, enter "20".

***If the "Highest No. Previously Paid For" IN THIS SPACE is less than 3, enter "3".

The Highest No. Previously Paid For" (Total or indep.) is the highest number found in the appropriate box in Col. 1 of a prior amendment or the number of claims originally filed.

- [] Please charge Deposit Account No. ____ in the amount of \$ ____ . Two (2) copies of this sheet are enclosed.
- [] Please charge fee of \$.00 for additional claims by Credit Card Payment Form PTO-2038 enclosed herewith
- [X] Please charge any deficiency as well as any other fee(s) which may become due under 37 C.F.R. § 1.16 and/or 1.17 at any time during the pendency of this application, or credit any overpayment of such fee(s) to Deposit Account No. 50-0679. Also, in the event any extensions of time for responding are required for the pending application(s), please treat this paper as a petition to extend the time as required and charge Deposit Account No. 50-0679 therefor. **TWO (2) COPIES OF THIS SHEET ARE ENCLOSED.**

Respectfully submitted,

F. CHAU & ASSOCIATES
130 Woodbury Road
Woodbury New York 11797
Tel: (516) 692-8888
Fax: (516) 692-8889

Thomas W. McNally
Reg. No. 48,609
Attorney for Applicant

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postpaid in an envelope, addressed to the: Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313 on **November 19, 2004.**

Dated: 19 November 2004

Thomas W. McNally



Attorney Docket: 8028-42 (SPX200304-0017US)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Kim, Hyun-Woo EXAMINER: Walke, Amanda C
SERIAL NO: 10/787,368 GROUP ART UNIT: 1752
FILED: February 26, 2004
FOR: **METHOD OF FORMING AN UNDERLAYER OF A BI-LAYER RESIST FILM AND METHOD OF FABRICATING A SEMICONDUCTOR DEVICE USING THE SAME**

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

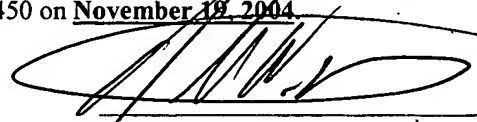
AMENDMENT

This is a response to an Office Action mailed on August 24, 2004. Please consider the following amendment and remarks to the above-identified application:

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postpaid in an envelope, addressed to the: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450 on November 19, 2004.

Dated: 19 November 2004


Thomas W. McNally